

Docket No.: 0965-0472PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yuichi KAWANO et al.

Application No.: 10/582,983

Confirmation No.: 8160

Filed: January 5, 2007

Art Unit: 1792

For: PLASMA PROCESSING APPARATUS

Examiner: V. Bernard

REPLY AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated January 4, 2008, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims

Remarks/Arguments